



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
 Address: COMMISSIONER FOR PATENTS
 P.O. Box 1450
 Alexandria, Virginia 22313-1450
 www.uspto.gov

BIB DATA SHEET

CONFIRMATION NO. 3893

SERIAL NUMBER	FILING or 371(c) DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.	
10/019,407	03/25/2002	438	2813	520.41003 X00	
RULE					
APPLICANTS Yoshinobu Kimura, Tokyo, JAPAN; Takahiro Kamo, Mobara, JAPAN; Yoshiyuki Kaneko, Hachioji, JAPAN;					
** CONTINUING DATA ***** This application is a 371 of PCT/JP00/04141 06/23/2000					
** FOREIGN APPLICATIONS ***** JAPAN 11/181559 06/28/1999					
** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **					
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and /LAURA MARY MENZ/ Acknowledged Examiner's Signature	<input type="checkbox"/> Met after Allowance Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 16	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 9
ADDRESS ANTONELLI, TERRY, STOUT & KRAUS, LLP 1300 NORTH SEVENTEENTH STREET SUITE 1800 ARLINGTON, VA 22209-3873 UNITED STATES					
TITLE Polysilicon semiconductor thin film substrate, method for producing the same, semiconductor device, and electronic device					
FILING FEE RECEIVED 1524	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		